

	Type	L #	Hits	Search Text	DBs	Time Stamp
1	BRS	L1	45936	microsphere\$4 or micro-sphere\$4 or microlens\$5 or micro-lens\$5	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/ 14 15:13
2	BRS	L2	2092	lenslet\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/ 14 15:11
3	BRS	L3	18961	spheroid\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/ 14 15:12
4	BRS	L4	1911442	diameter\$2	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/ 14 15:12
5	BRS	L5	3198	quantum adj3 dot\$2	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/ 14 15:12
6	BRS	L6	21728	1 and 4	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/ 14 15:12
7	BRS	L7	299	6 and 5	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/ 14 15:12
8	BRS	L8	12193	microlens\$5 or micro-lens\$5	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/ 14 15:13
9	BRS	L9	4074	4 and 8	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/ 14 15:14

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	Type	L #	Hits	Search Text	DBs	Time Stamp
10	BRS	L10	38	9 and 5	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/ 14 15:14
11	BRS	L11	332611	spheric\$6	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/ 14 16:00
12	BRS	L12	161	7 and 11	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/ 14 16:02
13	BRS	L13	149	12 not 10	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/ 14 16:04
14	BRS	L14	1792465	optical\$5	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/ 14 16:04
15	BRS	L15	132	13 and 14	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/12/ 14 16:04

	Document ID	1	Kind Codes	Source	Issue Date	Pages	Title
1	US 20040079893 A1	X		US PG PU B	200404 29	18	Novel optical architectures for microvolume laser- scanning cytometers
2	US 20030076649 A1	X		US PG PU B	200304 24	40	Method of forming an electronic device
3	US 20030032204 A1	X		US PG PU B	200302 13	30	Optical array device and methods of use thereof for screening, analysis and manipulation of particles
4	US 20020028045 A1	X		US PG PU B	200203 07	147	Optical coupling structures and the fabrication processes
5	US 6503831 B2	X		US PA T	200301 07	36	Method of forming an electronic device
6	US 6200737 B1	X		US PA T	200103 13	21	Photodeposition method for fabricating a three-dimensional, patterned polymer microstructure

	<b>Abstract</b>	<b>Current OR</b>	<b>Current XRef</b>
<b>1</b>		250/458.1	
<b>2</b>		361/524	257/E29.15 1; 257/E51.01 2
<b>3</b>		436/518	422/82.05; 435/288.7; 435/7.1
<b>4</b>		385/50	385/39
<b>5</b>		438/674	257/E29.15 1; 257/E51.01 2; 438/29; 438/30
<b>6</b>		430/320	422/82.06; 422/82.11; 430/321; 430/5

	Document ID	1	Kind Codes	So urce	Issue Date	Pa ges	Title
7	US 5583351 A	X		US PA T	199612 10	20	Color display/detector

	<b>Abstract</b>	<b>Current OR</b>	<b>Current XRef</b>
7		257/89	257/184; 257/201; 257/440; 257/443; 257/90; 257/E27.12; 257/E27.13 4; 257/E33.00 7; 257/E33.02 8; 257/E33.06 9